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Docket No.: SHIGA7.051APC

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Customer No. 20,995

1AP20 Resides Total 25 May 2006

INFORMATION DISCLOSURE STATEMENT

Applicant

Takeshita et al.

App. No

Unknown

Filed

Filed Herewith

For

POSITIVE RESIST COMPOSITION

FOR **FORMING** AND **METHOD**

RESIST PATTERN

Examiner

Unassigned

Art Unit

Unknown

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class an envelope addressed to: mail in Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

May 25, 2006

(Date)/

Neil S. Bartfeld, Ph.D., Reg. No. 39,9

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 21 references to be considered by the Examiner. Also enclosed are 14 foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed within three months of the filing date, with an RCE or before receipt of a first office action after an RCE and no fee is required.

The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.

By:

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: May 25, 2006

Neil S. Bartfeld, Ph.D.

Registration No. 39,901

Agent of Record

Customer No. 20,995

(619) 235-8550

10580768 - GAU: 1795 PTO/SB/08 Equivalent

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Application No.	-Unknows 10/580,768
Filing Date	Eiled Horowith , 05/25/2006
First Named Inventor	Masaru Takeshita
Art Unit	-Unknown 1795
Examiner	Unassigned Anca Eoff
Attorney Docket No.	SHIGA7.051APC
	Filing Date First Named Inventor Art Unit Examiner

U.S. PATENT DOCUMENTS						
Examir Initial	- 1	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
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Examiner Signature	/Anca Eoff/	Date Considered	05/19/2008

^{*}Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

T¹ - Place a check mark in this area when an English language Translation is attached.